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Docket Number (Optional) Application Number O2 MICRO 98.01 CON CIP 09/867,315 INFORMATION DISCLOSURE CIPATION (Use several sheets if necessary) Applicant(s) CHAN ET AL. Group Art Unit Filing Date AUG 3 1 2001 MAY 29, 2001 2752 U.S. PATENT DOCUMENTS TRADEULA FILING DATE EXAMINER CLASS SUBCLASS DOCUMENT NUMBER DATE NAME REF INITIAL IF APPROPRIATE 12/21/99 JACOBS ET AL. 710 14 6,006,285 710 1 8/20/96 woo 5,548,777 10th 710 124 b2 5,796,705 8/18/98 **KIM** 182 30, ZL 369 5,870,355 12/9/99 **FUJIHARA** 18812 6/8/99 MOORE 369 5,910,933 713 324 7/11/00 **ATKINSON** 6,088,809 750000 2332 895 TIS 5,838,983 11/17/98 ATKINSON 2/27/01 CHAIKEN ET AL. 710 19 6,195,713 710 14 7/24/01 JACOBS ET AL. 6,266,714 FOREIGN PATENT DOCUMENTS Translation CLASS SUBCLASS COUNTRY DATE REF DOCUMENT NUMBER Technology Center 2 00 OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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(Use several sheets if norosconnic) **O2MICRO 98.01 CON CIP** Applicant(s) **CHAN ET AL** Group Art Unit Filing Date MAY 29, 2001 PATENT DOCUMENTS FILING DATE EXAMINER CLASS SUBCLASS NAME DOCUMENT NUMBER DATE REF IF APPROPRIATE INITIAL 750 323 898 713 03/31/1995 NARAD ET AL 11/25/1997 US 5,692,197 713 100 601 01/17/1986 07/25/1989 DAY US 4,851,987 750 320 395 71<u>3</u> 06/23/1989 PERRY ET AL 08/25/1992 US 5,142,684 A951713 10/30/1989 06/08/1993 WATTS, JR. ET AL US 5,218,704 750 322 395 713 02/02/1994 04/23/1996 WISOR ET AL US 5,511,203 395 713 **759** 322 02/01/1995 09/24/1996 HARPER ET AL US 5,560,024 113 988 32Z SMITH ET AL 03/05/1992 11/24/1992 US 5,167,024 324 03/08/2001 ATKINSON 713 05/07/2002 US 6,385,734 B2 07/28/2000 710 19 05/21/2002 CHAIKEN ET AL US 6,393,499 B1 Technology/Genter.2600) FOREIGN PATENT DOCUMENTS Translation SUBCLASS COUNTRY CLASS DATE DOCUMENT NUMBER OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) DATE CONSIDERED EXAMINER EXAMINER: Initial if citation considered whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. Patent and Trademark Office * U.S. DEPARTMENT OF COMMERCE